

NOV 24 2004

PATENT APPLICATION  
Docket No. 4591-227  
Client No. IE10176-US

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Do-Hyung KIM and Sung-Eui KIM

Serial No. 10/083,756 Examiner: Vu, Quang D

Confirmation No. 2262

Filed: February 25, 2002 Group Art Unit: 2811

For: METHOD FOR FORMING LAYER FOR TRENCH ISOLATION  
STRUCTURE

MAIL STOP AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

## AMENDMENT

Responsive to the Office Action, dated August 24, 2004, please amend the application as follows.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.